



**RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE - EXAMINING GROUP 2620**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Tatsuya Kato et al.  
Application No. : 10/516,701  
Filed : December 1, 2004  
For : METHOD FOR DETERMINING PATTERN FOR MODULATING  
POWER OF LASER BEAM, AN APPARATUS FOR RECORDING  
DATA IN OPTICAL RECORDING MEDIUM AND OPTICAL  
RECORDING MEDIUM

Examiner : Minerva Rivero  
Art Unit : 2627  
Docket No. : 890050.514USPC  
Date : January 22, 2007

*110K to Endu  
2/16/07*

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT UNDER 37 CFR 1.116**

Commissioner for Patents:

In response to the Office Action dated October 20, 2006, please amend the application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 12 of this paper.

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